Advancing front-end readout ASICs with BiCMOS SiGe technology for ultra-fast sensors PhD Thesis Proposal

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BiCMOS SiGe for ultra-fast sensors

November 25, 2021 1 / 13

Muon Detection

• Aim: Improve muon detection in AMIGA [1] and ANDES [2] experiments



Schematic of Current AMIGA Muon Detection Setup [3], [4]

• One SiPM per scintillation bar

- connected to one readout channel in frontend
- Time resolution only by counting incoming photons in a certain time interval

Proposed Muon Detection Setup



Proposed Detector for one Scintillation Bar in ANDES

- High-granularity SiPM¹ of FBK[5] using 2D integration technology
 - reduced optical cross-talk due to trench isolation
 - pile-up mitigation
- SiPM bump-bonded to frontend ASIC
- Readout with high time resolution and high granularity
 - detection of angle of incoming photon and fiber delay
 - $\rightarrow\,$ improved muon hit position resolution

 $^{1}\text{joint}$ development between KIT-IPE and FBK

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Activities

• Design frontend readout ASIC for advanced SiPM technology

- with high-granularity
- each SPAD cell is readout individually
- photon counting with very high time resolution
- Characterization of designed ASIC
 - testing general functionality
 - timing characterization
 - testing under bad environmental conditions
- High-density integration by bump bonding of SiPM to ASIC
 - using gold-stud bumping at KIT-IPE [6]
- Testing of hardware with muon counter at ITeDA

SPAD Readout



Proposed Readout Chain for one Pixel/SPAD

Time Resolution

Time jitter ¹

$$\sigma_t = \frac{\sigma_n}{\frac{dV}{dt}|_{V_T}} \approx \frac{t_r}{S/N}$$

- High time resolution requires
 - Fast rise time
 - High signal to noise ratio



Threshold Crossing [7]

 ${}^{1}\sigma_{n} = \frac{S}{N}$, S: Signal amplitude, N: RMS-noise voltage $\langle a \rangle \rightarrow \langle a \rangle \rightarrow \langle a \rangle$

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The solution: Heterojunction Bipolar Transistors (HBT)

- High time resolution requires
 - Fast Amplifiers = high f_T



Transit frequency f_T HBT vs. MOSFET [8]

low noise

- Pixelated design requires
 - low area consumption



g_m vs. area of different technologies [8]

low power consumption

 $\rightarrow\,$ HBT offers better performance in analog circuits than CMOS

7/13

SiGe BiCMOS

- SiGe HBT performance very good for analog design
- CMOS has advantages for
 - low-power digital design
 - bias circuits, because PMOS available
- \rightarrow SiGe BiCMOS
 - Our process: IHP SG13G2 130 nm SiGe BiCMOS with $f_T = 300 \,\mathrm{GHz}$ [9]
 - IHP is a research institute working closely together with KIT
 - IHP offers the HBTs with highest f_T
 - PDK for Cadence Virtuoso design environment
 - already used for pixel sensors with high time resolution[10]



Summary

- New generation of SiPM for muon counters in AMIGA and ANDES experiments
- SiGe BiCMOS technology allows SiPM readout with
 - high granularity
 - high time resolution
- $\rightarrow\,$ ASIC development for measurements with high spatial and time resolution

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IHP: https://www.ihp-microelectronics.com/

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Back-up

Cadence Virtuoso



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November 25, 2021 2,

2/2